

Simulation of SiC detector

Suyu Xiao on behalf of RASER Team

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2nd DRD3 Week on Solid State Detectors R&D

Advantages of silicon carbide

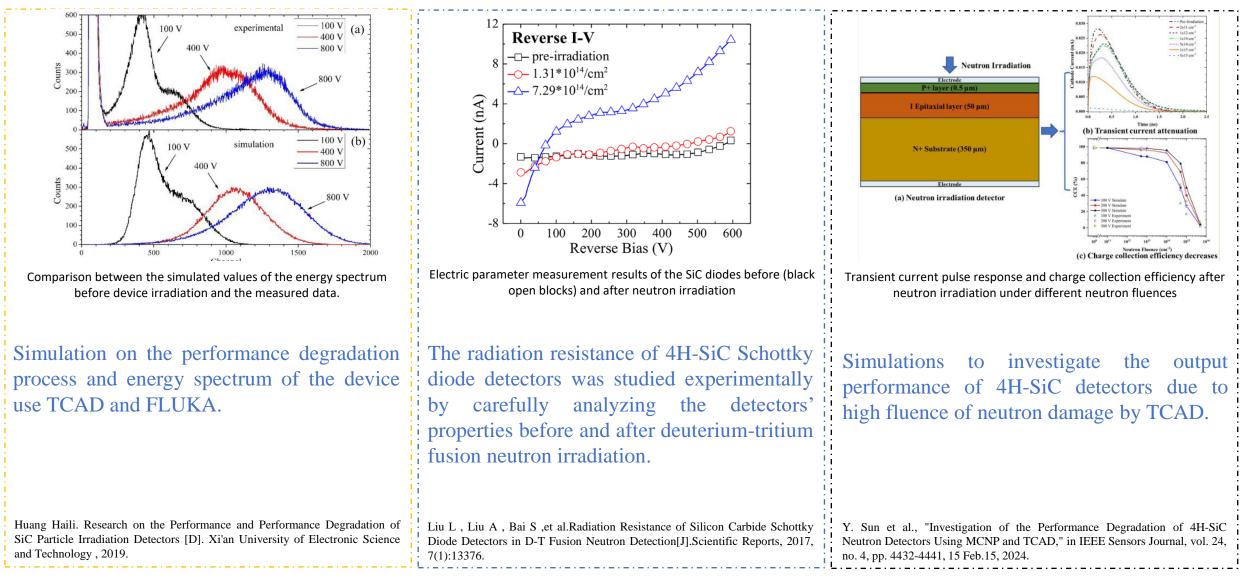
With the increase of collision brightness and detector size, silicon are facing two challenges:

- Near the limit of irradiation-hard \rightarrow replace detector regularly
- Leakage current increases with irradiation \rightarrow cooling equipment

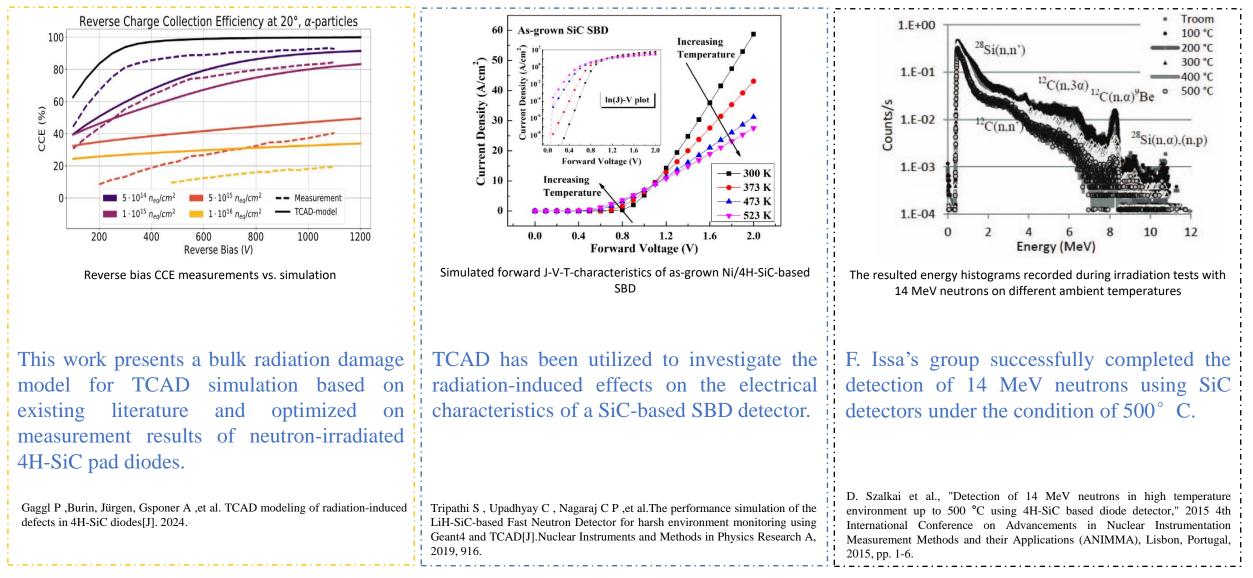
Silicon carbide is expected to achieve breakthroughs in the above two aspects.

物理量	Si	SiC	Low noise Irradiation-hard 带隙 [eV] 阈位移能量 [eV]
Bandgap[eV]	1.12	3.26	SiC
Thermal conductivity[W/K cm]	1.5	4.9	Good timing
Breakdown[MV/cm]	0.3	2.0	resolution · · · · · · · · · · · · · · · · · · ·
Atomic displacement threshold energy[eV]	13	22	
Average ionization energy[eV/e-h]	3.6	7.8	
Electron saturation drift velocity[cm/s]	1×10^{7}	2×10^{7}	↓ ↓ 击穿电场 [MV/cm] 导热系数 [W/(cm⋅K)]
Hole saturation drift velocity[cm/s]	0.6×10 ⁷	1.8×10^{7}	High bias voltageWorking at roomtemperature

Irradiation studies of SiC



Irradiation studies of SiC

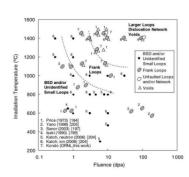


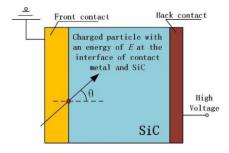
Challenges in SiC detector research

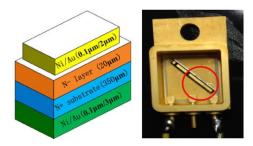
- Irradiation damage mechanism of SiC materials not clear
 - The analysis of experimental results is more inclined to summarize the experimental results and qualitatively explain the device performance or the variation laws of the experimental results.
- Irradiation model of SiC detector incomplete
 - During the research process of SiC particle irradiation detectors, there is a lack of an analytical method that can comprehensively analyze the impacts of different factors on the final output of the detectors, as well as a series of physical models used to describe the damage to the devices.

Lack of reliable detector with new structures

• Extreme and complex radiation detection environments mean that the scale and structure of existing semiconductor detectors can no longer gradually meet future nuclear detection requirements. It is necessary to design new detector structures to fulfill the radiation detection needs of the future.







• Study the defects generated during irradiation and the performance changes of SiC detector

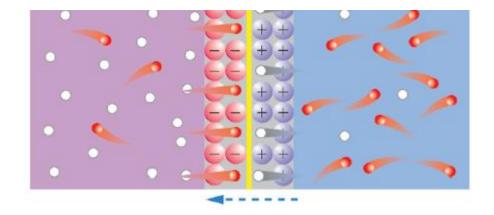
- Improve the theoretical model to predict the performance of SiC detector after irradiation **Focusing**
- Develop SiC detector with new structures to improve its irradiation hardness

Research content

- Research on material characteristics to gain understanding of the physical changes of SiC after irradiation
 - Influence mechanism of carrier mobility
 - Transport: based on electric field, calculate the carrier mobility and diffusion coefficient using the diffusion and drift equations
- Improve theoretical model to explain and predict the behavior of SiC after irradiation
 - Recombination: such as scattering and trap recombination, establish rate equations to describe the disappearance process of carriers
 - Influence of different types of irradiation particles
 - Some empirical parameters from fitting
- Methods to reinforce detectors and improve service life
 - Materials: special doping
 - Process: annealing
 - Special structures: multilayer structures and heterojunctions

Research plan

Influence mechanism of carrier mobility



• Diffusion process: carriers move from regions of high concentration to low concentration due to the non-uniform carrier concentration in space caused by thermal motion

$$rac{\partial n(x,t)}{\partial t} = D_n rac{\partial^2 n(x,t)}{\partial x^2}, \qquad rac{\partial p(x,t)}{\partial t} = D_p rac{\partial^2 p(x,t)}{\partial x^2} \qquad D = rac{kT}{q} \mu$$

• Drift process: directional movement of carriers under the action of an electric field

$$v_n = -\mu_n E$$
 $v_p = \mu_p E$

Research plan

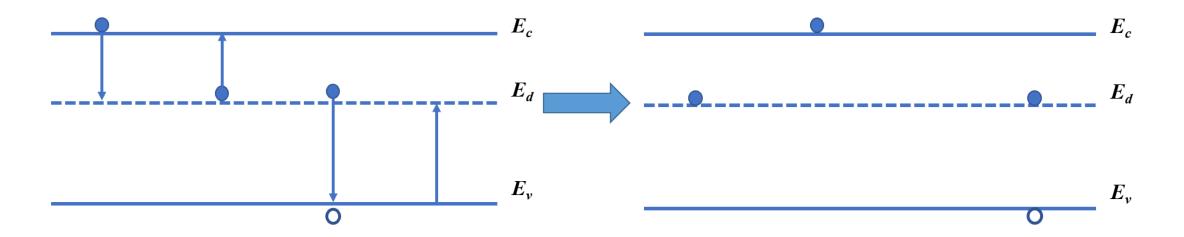
Recombination: such as scattering and trap recombination

Shockley-Read-Hall model: impurities and defects as recombination centers

recombination rate: $R_{SRH} = rac{C_n C_p (np-n_i^2)}{C_n (n+n_1)+C_p (p+p_1)}$

• Trap- recombination model: distribution of trap energy levels

recombination rate: $R_{trap} = \sum_{i} R_{trap,i}$



Research plan

Methods to reinforce detectors and improve service life

- Materials: Special Doping
 - Doping can change the band structure of semiconductors.
 - Impurity atoms can form stable defect complexes with irradiation-induced defects, suppressing the evolution of defects.
- Process: Annealing
 - Recovery of irradiation-induced defect damage.
- Special Structures: Multilayer Structures or Heterojunctions
 - Low Gain Avalanche Detector

Research foundation

An open-source fast simulation software RAdiation SEmi-conductoR(RASER)

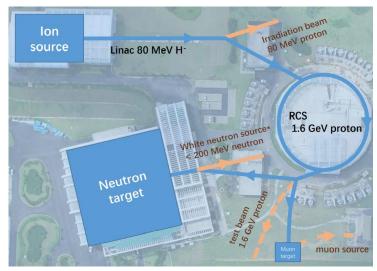
- Particle incident path and deposition energy distribution: GEANT4
- Electric and weighting field from Poisson and Laplace equation: DEVSIM

$$abla^2 \vec{\mathrm{U}}(r) = -\frac{
ho}{\epsilon}, \quad
abla^2 \vec{\mathrm{U}}_w(r) = 0$$

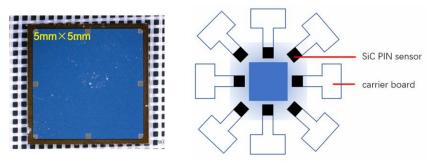
- Electronic simulation: amplifier model, NGSpice
- **Induced current:** $I(t) = -q \vec{v} (\vec{r}(t)) \cdot E_w(\vec{r}(t))$

Research foundation

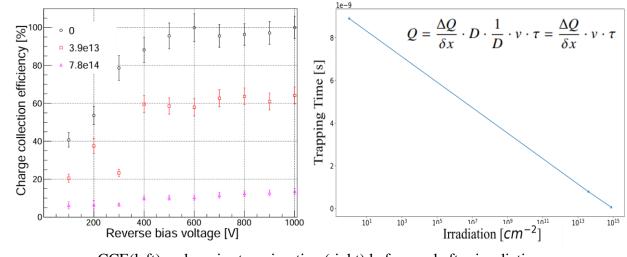
SiC PIN irradiation study as beam monitor for 1.6GeV proton beam line in China Spallation Neutron Source



New 1.6GeV proton beam line



SiC PIN(left) and detector placement in beam(right)

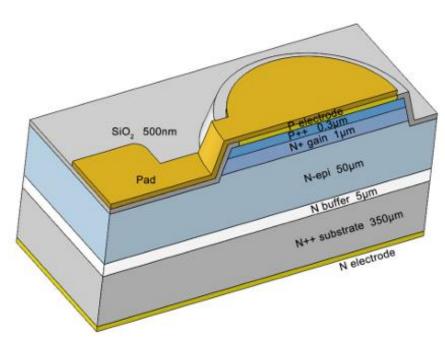


CCE(left) and carrier trapping time(right) before and after irradiation

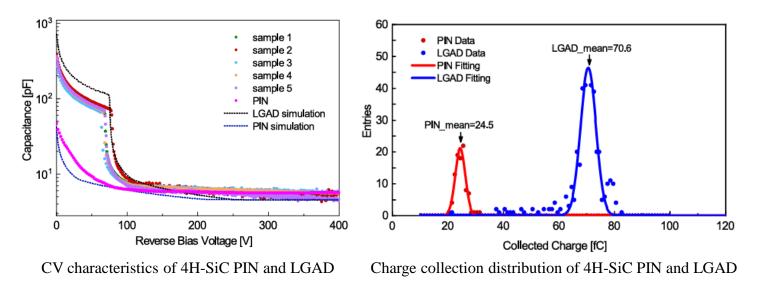
- The feasibility of SiC for beam monitoring has been demonstrated through irradiation experiment.
- RASER to calibrate SiC for long-term use, with the relationshop between carrier trapping time and irradiation dose.

Research foundation

SiC LGAD development



Cross-sectional schematic of the 4H-SiC LGAD detector



- SiC LGAD is fabricated and CV curve shows an obvious gain structure.
- The gain factor of SiC LGAD is \sim 3 at 350V in α detection.

Summary

WG4 research goals <2027					
	Description				
RG 4.1	Flexible CMOS simulation adaptable to different tech- nology nodes and development of connections between tools for device-level simulation and electronic circuit de- sign/validation				
RG 4.2	Implementation of newly measured semiconductor proper- ties into TCAD and MC simulations tools				
RG 4.3	Definition of benchmark for validating the radiation damage models with measurements and different benchmark models.				
RG 4.4	Developing of bulk and surface model for 10^{16} cm ⁻² $< \Phi_{eq} < 10^{17}$ cm ⁻²				
RG 4.5	Collate solutions from different MC tools and develop an algorithm to include adaptive electric and weighting fields				

WG4 research goals in the period 2024 - 2026 from DRD3 Proposal

- Our proposal meets WG4 research goals.
- Sincerely invite cooperations!
- Contact: suyu.xiao@iat.cn

Thank you!